



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

application of
Koji MISHIMA et al. : Confirmation No. 6334
Serial No. 10/660,483 : Attorney Docket No. 2003_1305
Filed September 12, 2003 : Group Art Unit 1742
METHOD AND APPARATUS FOR PLATING
SUBSTRATE WITH COPPER : Examiner William T. Leader
SUBSTRATE WITH COPPER : Mail Stop: RCE

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

A first month extension having been previously obtained, Petition is hereby made for a second and third month extension of time to respond to the communication of July 12, 2005.

The fee of \$900.00 is

submitted herewith.
 to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

 Small entity status of this application is established by a Small Entity Status Assertion which
 is enclosed.
 has been previously submitted.

Respectfully submitted,

Koji MISHIMA et al.

By _____

W. Douglas Hahn
Registration No.44,142
Attorney for Applicants

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December 29, 2005